



Attorney Docket SEL 189

IFU 2811

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
Takayama et al. )  
Serial No.: 09/598,736 )  
Filed: June 21, 2000 )  
For: Wiring Material, Semiconductor Device )  
Provided With A Wiring Using The Wiring )  
Material And Method Of Manufacturing Thereof )  
Art Unit: 2811 )  
Examiner: Hung K. Vu )

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450 on

*June 26 2006*

(Date of Deposit)

Shannon Wallace

Name of applicant, assignee, or Registered Rep.

*Shannon Wallace 6/26/06*

Signature

Date

**AMENDMENT (G)**

Sir:

In response to the Office Action of March 24, 2006, please amend the above-identified application as follows: